

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Foreign patent application of  
Yukitoshi INUI, et al.

Serial No.: 10/693,605

Group Art Unit: 1762

Filed: October 27, 2003

Examiner: Alain L. Bashore

For: MATERIAL COMPOSITION FOR PRODUCING OPTICAL  
WAVEGUIDE AND METHOD FOR PRODUCING OPTICAL  
WAVEGUIDE

Commissioner for Patents  
Alexandria, Virginia 22313-1450

**INFORMATION DISCLOSURE STATEMENT**

Sir:

Under the provisions of 37 CFR §1.97 through §1.99 and pursuant to applicants' duty of disclosure under 37 CFR §1.56, applicants respectfully bring the following documents cited in the Japanese Office Action dated February 15, 2007, in a counterpart foreign application, and listed on the attached form PTO-1449, to the attention of the Examiner in charge of the above-identified application. A copy of one of the listed documents are provided herewith for the convenience of the Examiner.

In compliance with the requirements of 37 CFR §1.98(a)(3), as a concise statement of relevance, as it is presently understood by the individual designated in 35 U.S.C. §1.56(c) most knowledgeable about the content of the information, the undersigned attorney of record submits a translation of an official action by a foreign examiner in which the references were cited. The relevance to the pending U.S. patent application is that the references were cited in a foreign patent application on the same subject matter. However, no independent analysis of the references, the accuracy of the statement of the foreign examiner or the claims of the foreign application under the laws of that country or the United States relative to the subject matter claimed in the present application has been made, the present understanding of the contents thereof by the undersigned being based on the translation of the foreign examiner's comments submitted herewith.

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This citation does not constitute an admission that the references are relevant or material to the claims. They are only cited as constituting related art of which the applicants are aware.

Serial No.: 10/693,605  
Docket No. T36-160634/SW  
NGB.318

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It is respectfully requested that the listed references be considered by the Examiner and formally made of record in this application.

A check in the amount of \$180.00 to cover the Information Disclosure Statement fee is submitted herewith.

Please charge any deficiencies in fees and credit any overpayment of fees to Attorney's Deposit Account No. 50-0481.

Respectfully submitted,



Sean M. McGinn  
Registration No. 34,386

Date: 8/30/07

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# INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)



Docket Number (Optional)

T36-160634/SW

Application Number

10/693,605

Applicant(s)

Yukitoshi INUI, et al.

Filing Date

October 27, 2003

Group Art Unit

1762

## PATENT DOCUMENTS

EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

## U.S. PATENT APPLICATION PUBLICATIONS

EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

## FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
		<del>2000-347043</del>	<del>12/15/2000</del>	<del>Japan</del>	<del>PREVIOUSLY SUBMITTED WITH IDS dated 4/13/04</del>			
		<del>2002-169038</del>	<del>06/14/2002</del>	<del>Japan</del>	<del>PREVIOUSLY SUBMITTED WITH IDS dated 4/13/04</del>			
		2003-131064	05/08/2003	Japan				ABS

## OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages, Etc.)

Japanese Office Action dated February 15, 2007 with English translation

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.